## Search Notes



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Applicant(s)/Patent Under Reexamination

SOBCHAK ET AL.

Examiner

Art Unit

Lee, Siu M

2611

## **SEARCHED**

| Class | Subclass                                    | Date      | Examiner   |
|-------|---------------------------------------------|-----------|------------|
| 375   | 346, 347, 348, 350, 316, 143, 152, 234, 229 | 4/12/2007 | Siu M. Lee |
| 455   | 67.11, 63.1, 522                            | 4/12/2007 | Siu M. Lee |

| SEAF | RCH N | NOTES |
|------|-------|-------|
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| Search Notes                       | Date      | Examiner   |
|------------------------------------|-----------|------------|
| EAST                               | 4/12/2007 | Siu M. Lee |
| IEEE                               | 4/12/2007 | Siu M. Lee |
| Discuss application with Chieh Fan | 4/12/2007 | Siu M. Lee |

## **INTERFERENCE SEARCH**

| Class | Subclass | Date | Examiner |
|-------|----------|------|----------|
|       | ·        |      |          |